



IPW

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of

Ravkin et al.

Application No: 10/607,611

Filed: June 27, 2003

For: APPARATUS AND METHOD FOR  
DEPOSITING AND PLANARIZING THIN FILMS )  
OF SEMICONDUCTOR WAFERS )

)  
) Examiner: Unassigned  
)  
) Art Unit: 2812  
)  
) Atty. Docket No: LAM2P428  
)  
) Date: November 19, 2004  
)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313-1450, on November 19, 2004.

Signed: Kay Harlow

Kay Harlow

INFORMATION DISCLOSURE STATEMENT  
UNDER 37 CFR §§1.56 AND 1.97(e)

Mail Stop: DD  
Commissioner of Patents and Trademarks  
Alexandria, VA 22313-1450

Dear Sir:

The references listed in the attached PTO Form 1449, copies of which are attached, may be material to examination of the above-identified patent application. Applicants submit these references in compliance with their duty of disclosure pursuant to 37 CFR §§1.56 and 1.97. The Examiner is requested to make these citations of official record in this application.

The undersigned hereby certifies that the references enclosed herewith were cited in a Search Report from a foreign patent office less than three months before the filing date of the present Information Disclosure Statement. A copy of the Search Report is enclosed herewith. Accordingly, it is respectfully submitted that no fee is due in conjunction with the filing of this IDS.

This Information Disclosure Statement is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that these references indeed constitute prior art.

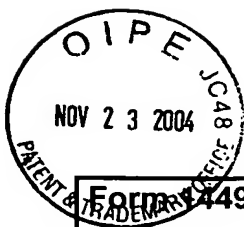
If the Commissioner should determine that additional fees are required for filing the present Information Disclosure Statement, the Commissioner is hereby authorized to charge any such fees to our deposit account number 50-0805 (Order No: LAM2P428). A copy of this sheet is enclosed.

Respectfully submitted,  
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Attorney Docket No. LAM2P428



<b>Form 449 (Modified)</b>  <b>Information Disclosure Statement By Applicant</b>  (Use Several Sheets if Necessary)	Attorney Docket No:	U.S.
	LAM2P428	10/607,611
	Applicants:	
	Ravkin et al.	
	Filing Date:	Group:
	June 27, 2003	2812

### U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class
	A	5,830,334	11/1998	Kobayashi	204	224 R
	B	6,132,586	10/2000	Adams et al.	205	123
	C	US 6,391,166 B1	05/2002	Wang	204	224 R
	D	US 6,341,998 B1	01/2002	Zhang	451	41
	E					
	F					
	G					
	H					
	I					

### Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No
	J	58-37190 (Patent Abstract In English)	04/03/83	JP	C25D	5/02		X
	K	08277486 (Patent Abstract In English)	22/10/96	JP	C25D	5/02		X
	L							
	M							
	N							

### Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
	O	
	P	
Examiner	Date Considered	

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.